



1763
\$

PATENT
Attorney Docket No. 7363.0010

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Reissue Application of:)

U.S. Patent No.: 5,792,261)

Inventor: Kiichi HAMA et al.)

Issued: August 11, 1998)

Serial No.: 09/478,370)

Filed: January 6, 2000)

For: PLASMA PROCESS
APPARATUS)

Group Art Unit: 1763

Examiner: Alejandro Mulero, L.

RECEIVED
SEP 10 2001
TC 1700

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

PETITION FOR EXTENSION OF TIME

Applicants hereby petition for a three-month extension of time to respond to the Office Action of March 27, 2001. A fee of \$890.00 is enclosed herewith.

If there are any other fees due in connection with the filing of this response, please charge the fees to our Deposit Account No. 06-0916. If a fee is required for an extension of time under 37 C.F.R. § 1.136 not accounted for above, such an extension is requested and the fee should also be charged to our Deposit Account.

Respectfully submitted,

09/07/2001 FFANAEIA 00000040 09478370

01 FC:117

890.00 DP

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

By: _____

James W. Edmondson
Reg. No. 33,871

Dated: September 6, 2001

LAW OFFICES

FINNEGAN, HENDERSON,
FARABOW, GARRETT,
& DUNNER, L.L.P.
1300 I STREET, N. W.
WASHINGTON, DC 20005
202-408-4000